

Technische Universität Graz

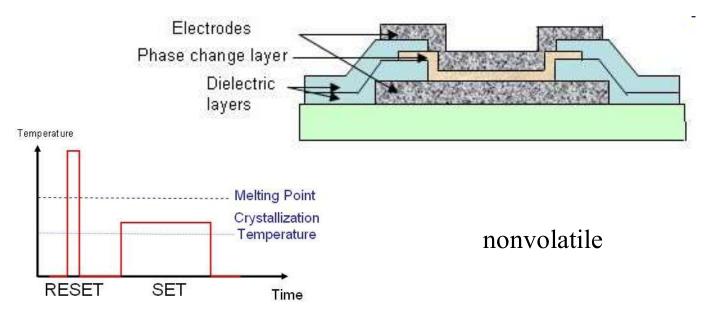
Institute of Solid State Physics

# MOSFETs and the future of microelectronics

## Phase change memory

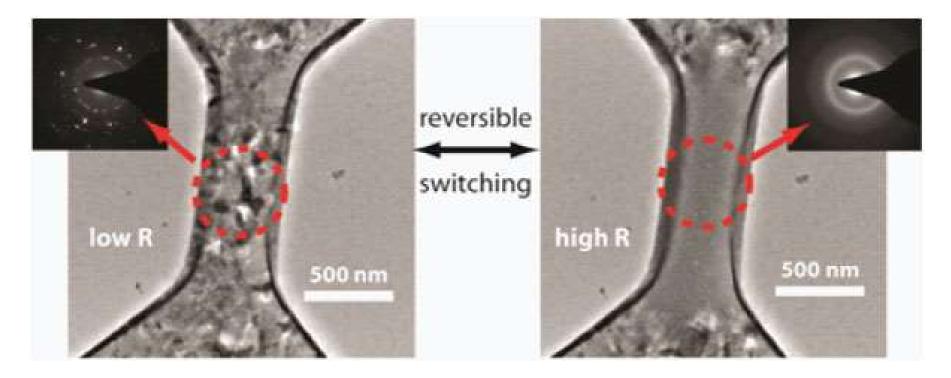
Phase-change memory (PCM) uses chalcogenide materials. These can be switched between a low resistance crystalline state and a high resistance amorphous state.

GeSbTe is melted by a laser in rewritable DVDs and by a current in PCM.



## Phase change material

#### Electron diffraction in a TEM of a GeSbTe alloy.

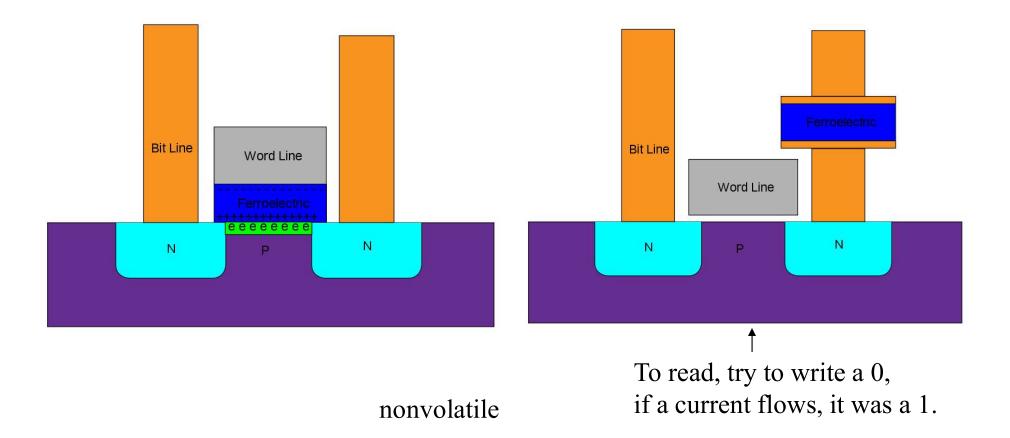


http://web.stanford.edu/group/cui\_group/research.htm

## Ferroelectric RAM

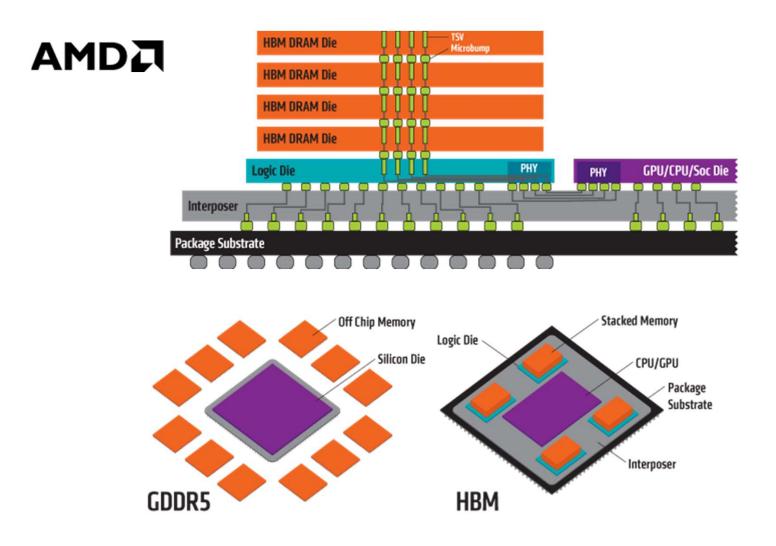
FeRAM uses a Ferroelectric material like PZT to store information.

Sometimes used in smart cards.

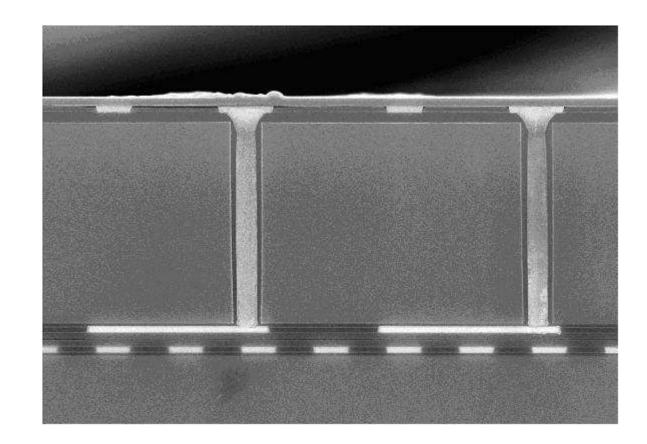


## High Bandwidth Memory

AMD to launch its HBM graphics cards on 16 June 2015.



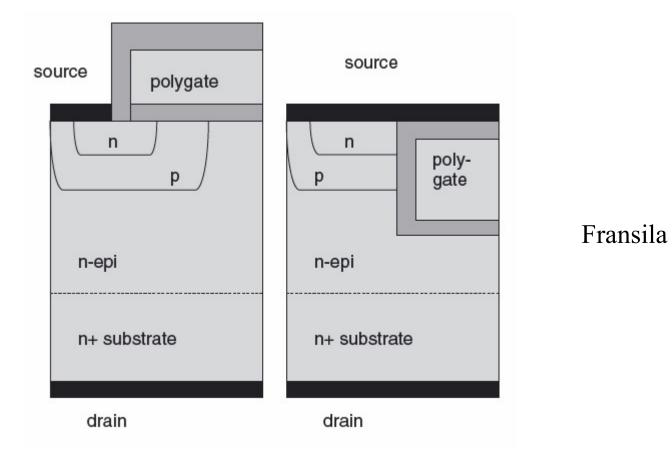
## Through-Silicon Via (TSV)



A vertical electrical connection (via) passing completely through a silicon wafer.

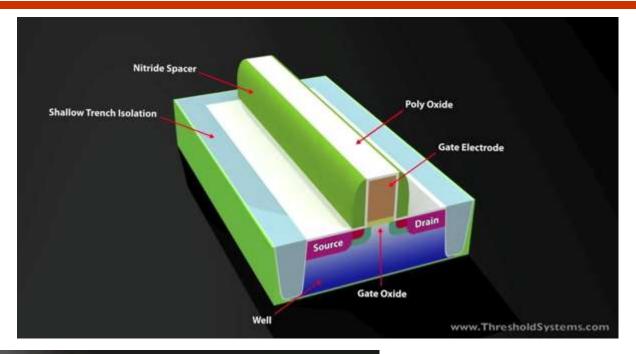
Used in 3D integration.

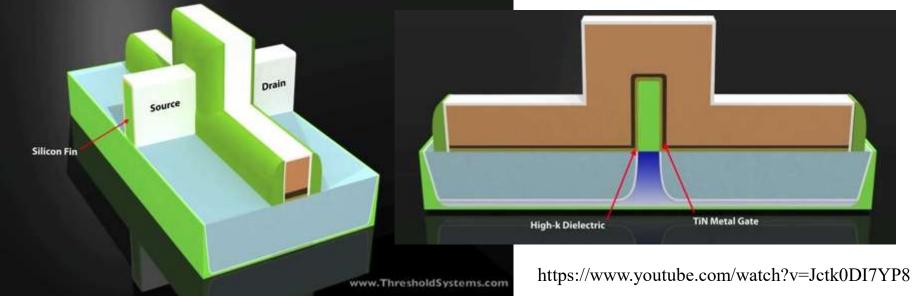
## U-MOSFET and D-MOSFET



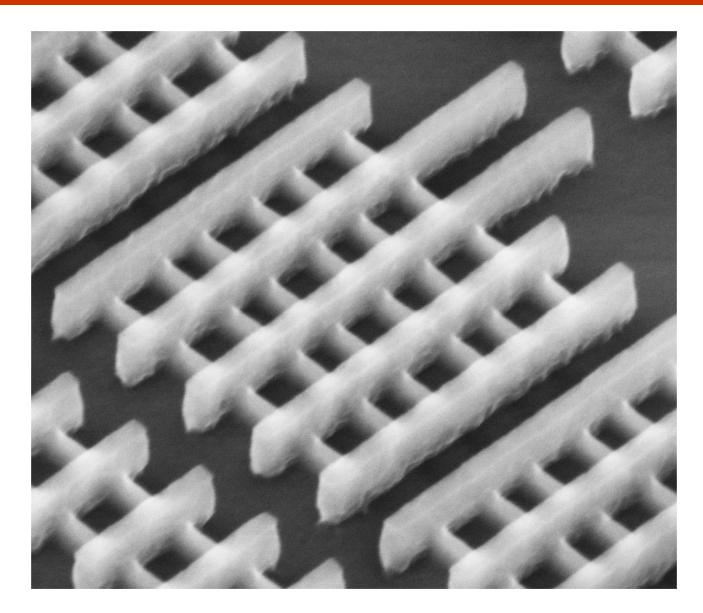
#### Power transistors

## FinFET



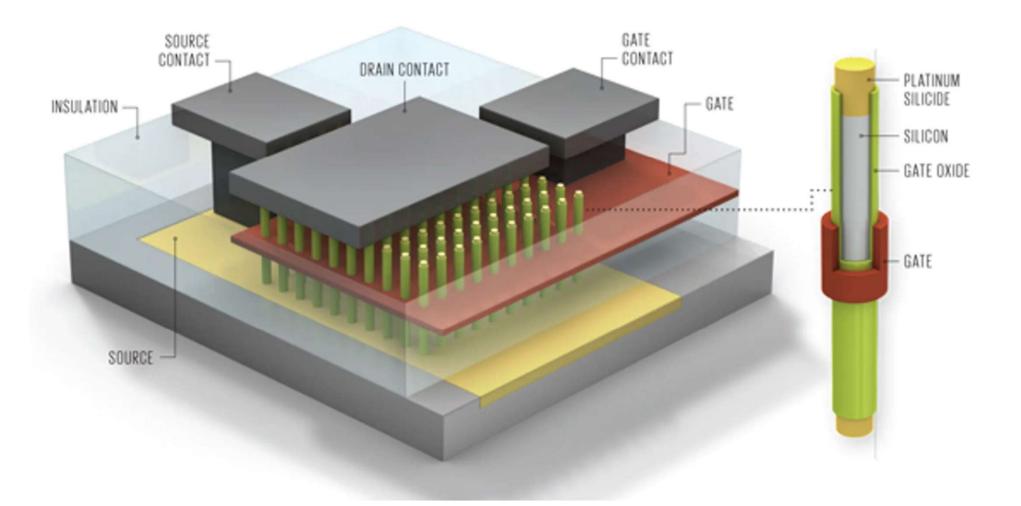


## Intel 22nm 3D tri-gate transistor



http://download.intel.com/newsroom/kits/22nm/gallery/images/Intel-22nm\_Transistor.jpg

#### Gate All Around (GAA)



IEEE Spectrum, 29 Apr. 2013



INTERNATIONAL ROADMAP FOR DEVICES AND SYSTEMS

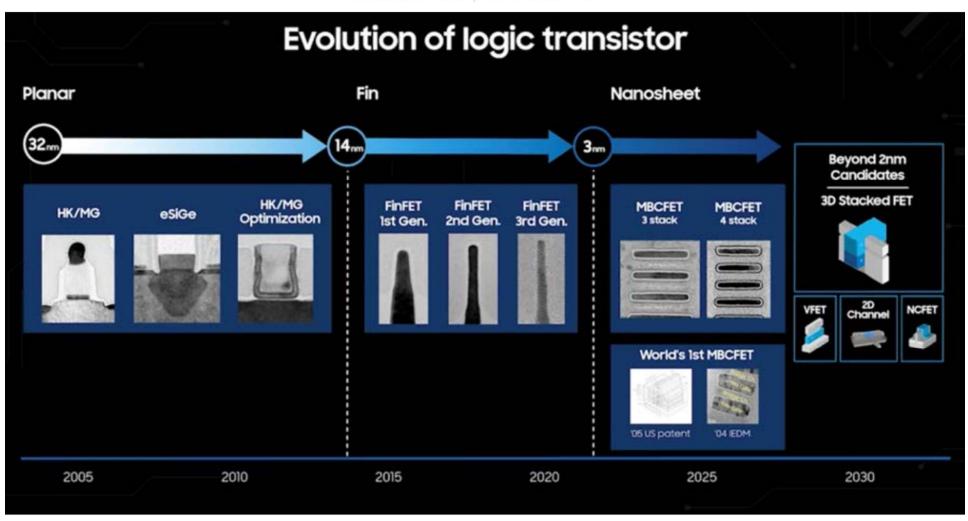
## INTERNATIONAL ROADMAP FOR DEVICES AND SYSTEMS<sup>™</sup>

2022 Edition

EXECUTIVE SUMMARY



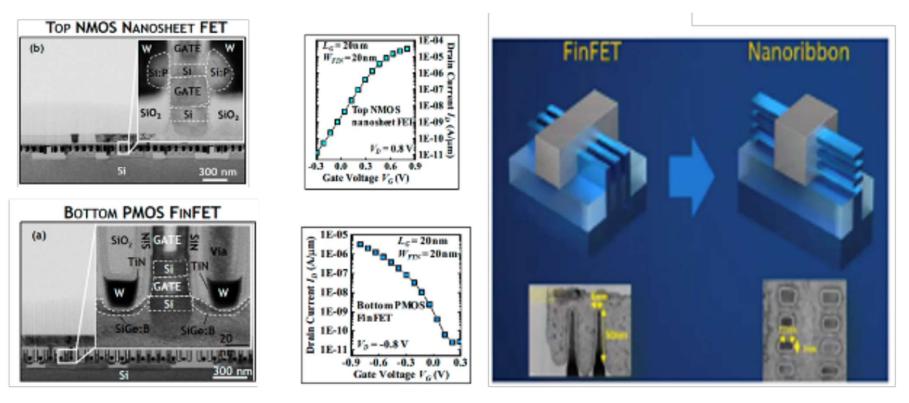
INTERNATIONAL ROADMAP FOR DEVICES AND SYSTEMS



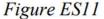
https://irds.ieee.org/editions/2022/executive-summary



INTERNATIONAL ROADMAP FOR DEVICES AND SYSTEMS



Source: IMEC and Intel

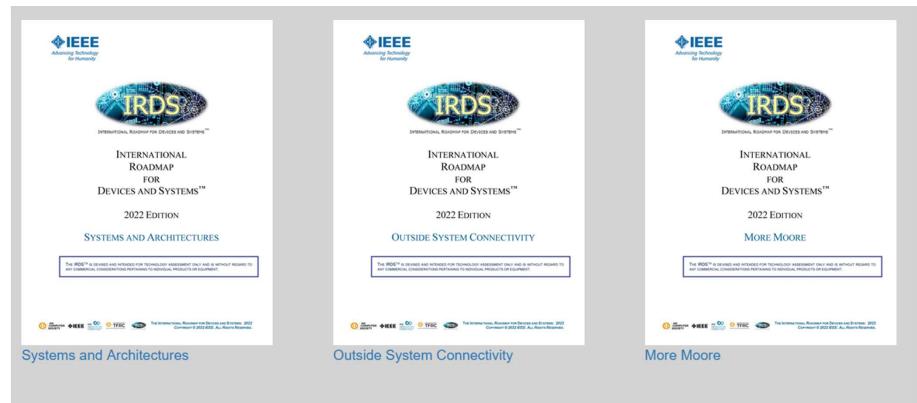


D. Vertical transistors and nanoribbons are progressively entering the logic technology arsenal

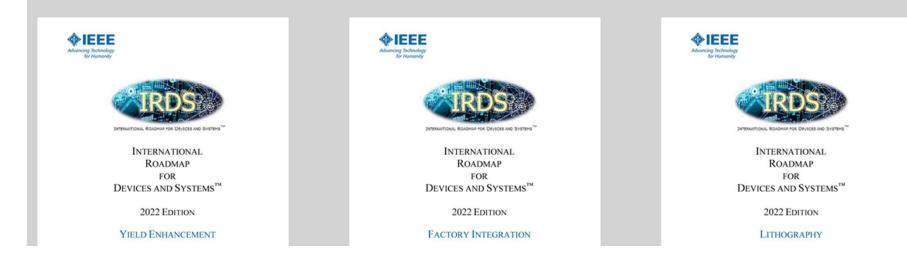
https://irds.ieee.org/editions/2022/executive-summary

#### 2022 Roadmap

	2022	2025	2028	2031	2034	2037
	G48M24	G45M20	G42M16	G40M16/T2	G38M16/T4	G38M16/T6
-	"3nm"	"2nm"	'4.5nm''	'4.0nm eq"	"0.7nm eq"	"0.5nm eq"
	Stacking	Stacking	Stacking	3DVLSI	3DVLSI	3DVLSI
	finFET LGAA	LGAA	LGAA	LGAA-3D	LGAA-3D	LGAA-3D
			CFET-SRAM	CFET-SRAM	CFET-SRAM	CFET-SRAM
		1.014	LGAA	LGAA-3D	LGAA-3D	LGAA-3D
	finFET	LGAA	CFET-SRAM	CFET-SRAM-3D	CFET-SRAM-3D	CFET-SRAM-3D
	Cxide	Cxipe	Oxine Oxine	tier tier tier	tier tier tier	tier tier tier
Mx pitch (nm)	32	24	20	16	16	16
M1 pitch (nm)	32	23	21	20	19	19
M0 pitch (nm)	24	20	16	16	16	16
Gate pitch (nm)	48	45	42	40	38	38
Lg: Gate Length - HP (nm)	16	14	12	12	12	12
Lg: Gate Length - HD (nm)	18	14	12	12	12	12
Channel overlap ratio - two-sided	0.20	0.20	0.20	0.20	0.20	0.20
Spacer width (nm)	6	6	5	5	4	4



#### https://irds.ieee.org/editions/2022





INTERNATIONAL ROADMAP FOR DEVICES AND SYSTEMS

#### INTERNATIONAL ROADMAP FOR DEVICES AND SYSTEMS<sup>™</sup>

2022 Edition

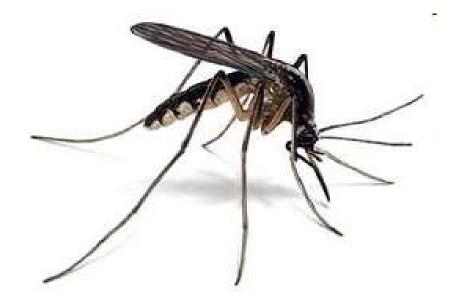
BEYOND CMOS AND EMERGING MATERIALS INTEGRATION



Technische Universität Graz

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#### Organic microprocessor



A modern computer has the processing power of a mosquito brain.



## Miniaturization ends with CMOS

There are no technologies (single electron transistors, molecular electronics, superconducting electronics, spintronics, NEMs...) that can provide performance similar to CMOS at a **much** smaller size scale.

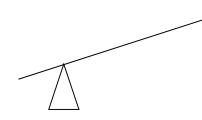
There are presently no transistors cheaper than silicon transistors

Candidates for orders of magnitude improvements of performance are quantum computing and molecular electronics.



## Gain requires leverage

There are two lengths in an amplifier.

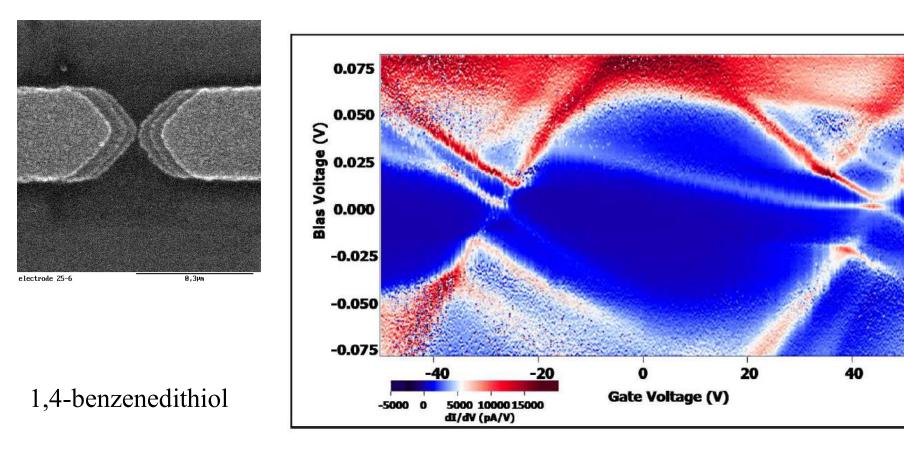


In CMOS the gate insulator is much thinner than the gate length.

If the short length is 1 nm, the long length is 10 nm.

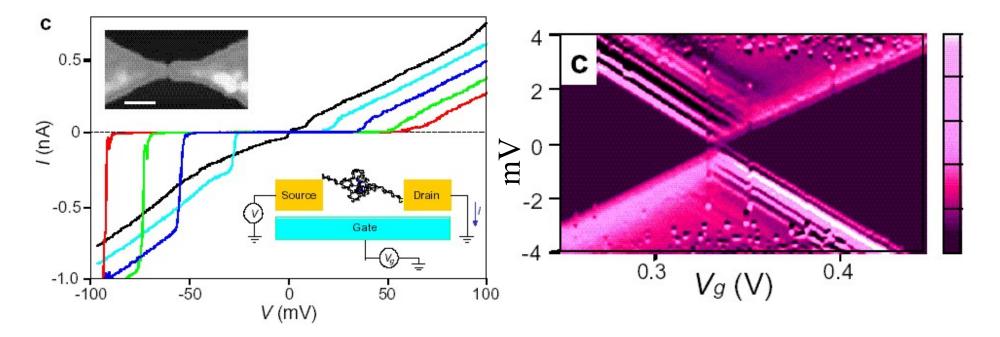
## Measuring molecules





Results are unreproducible

### Molecular electronics



Jiwoong Park, Abhay N. Pasupathy, Jonas I. Goldsmith, Connie Chang, Yuval Yaish, Jason R. Petta, Marie Rinkoski, James P. Sethna, Héctor D. Abruña, Paul L. McEuen, and Daniel C. Ralph, Nature 417 p. 722 (2002).

Use big 'molecules' as electronic components

Easier to make reproducible contacts.

Au

InAs

InP

InAs

InP

InAs

InP

InAs

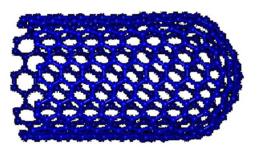
InP

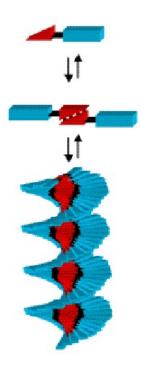
InAs

0011

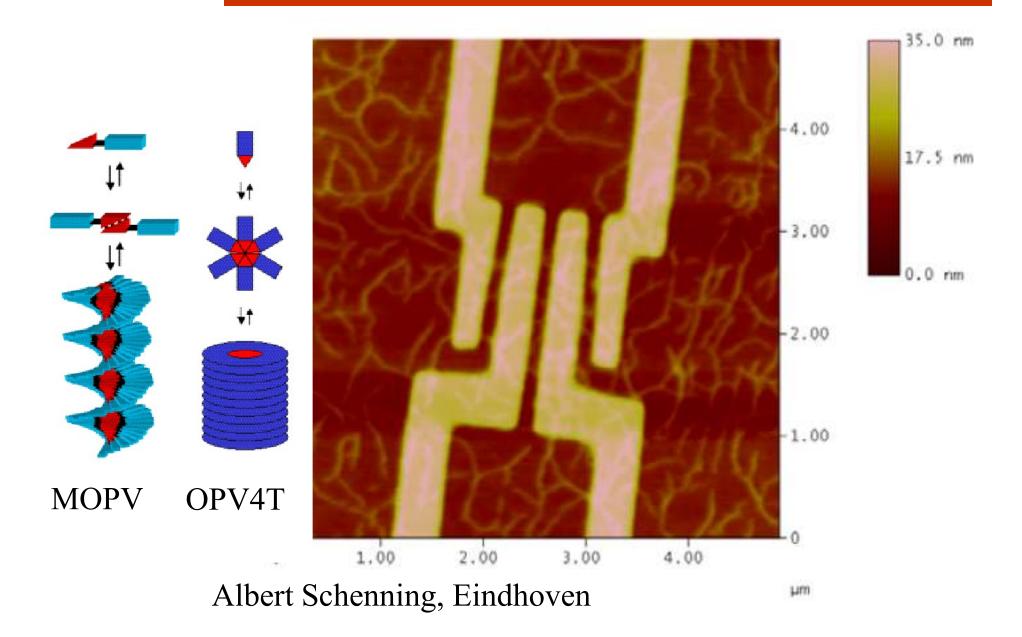
110](•

- Imaging of individual molecular assemblies possible
- Nanowires or nanocrystals of conventional semiconductors

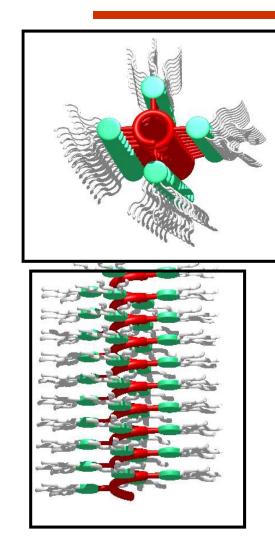




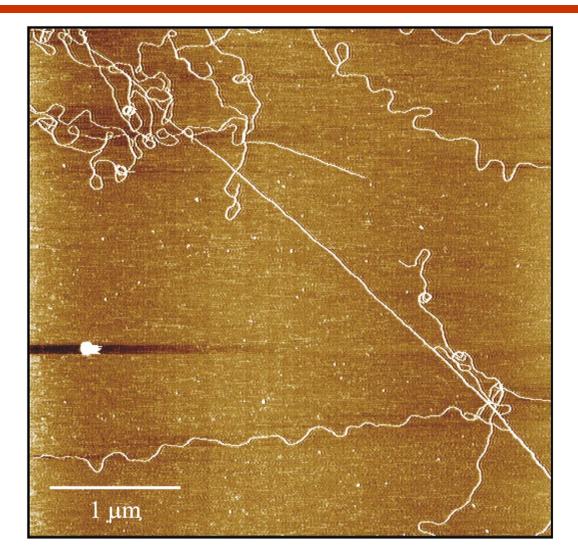
## AFM image of MOPV4 fibers



## Using templates for self-assembly

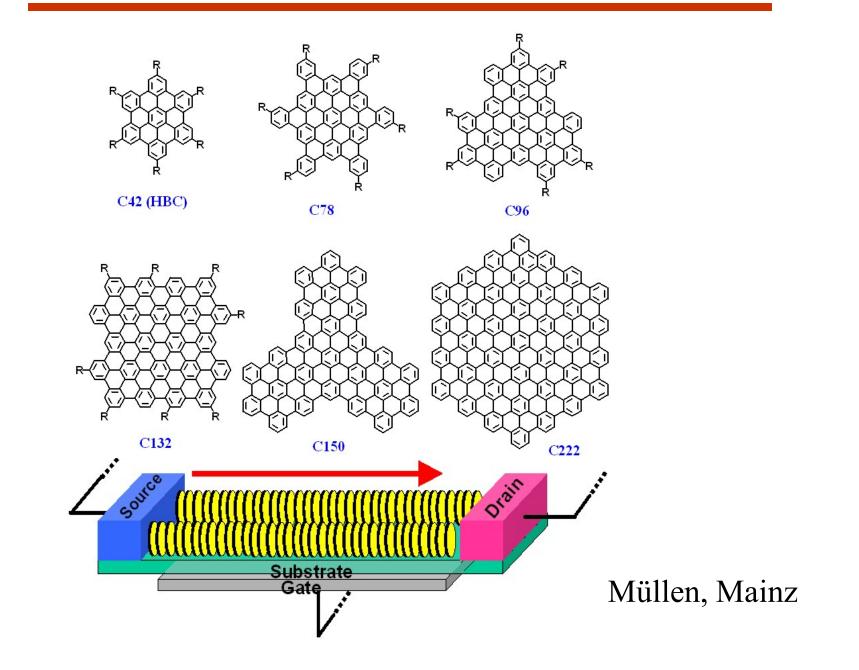


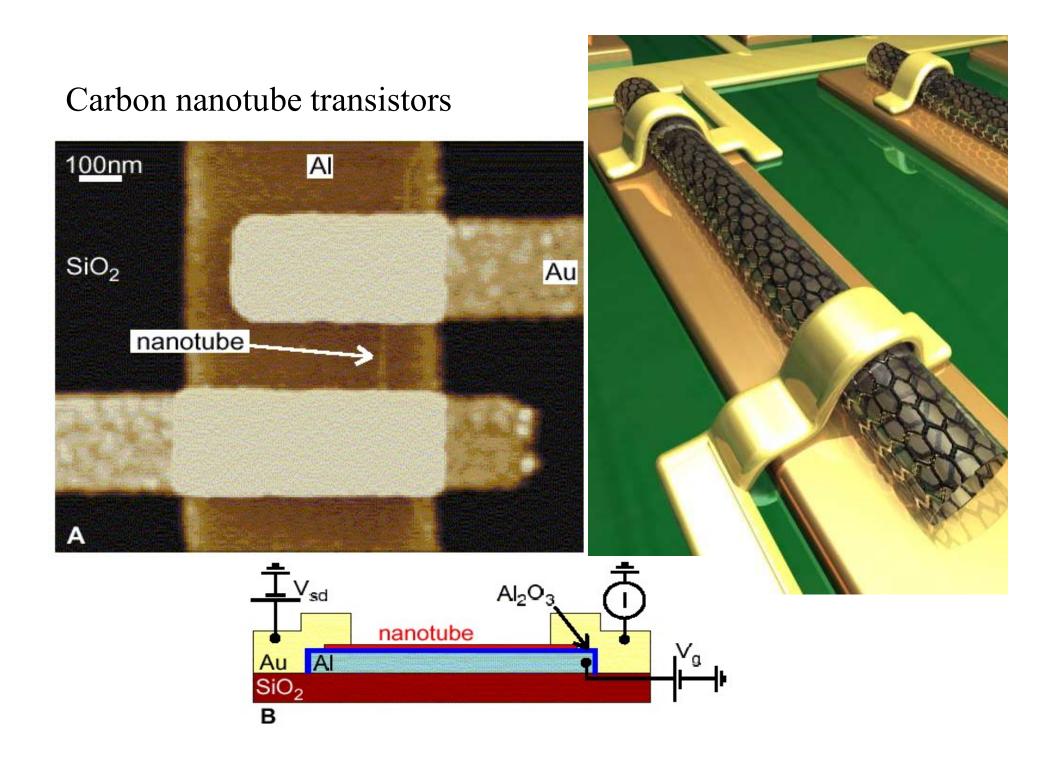
Alan Rowan, Nijmegen



Phthalocyanine Polyisocyanides

## hexabenzocoronenes







International Technology Roadmap for Semiconductors

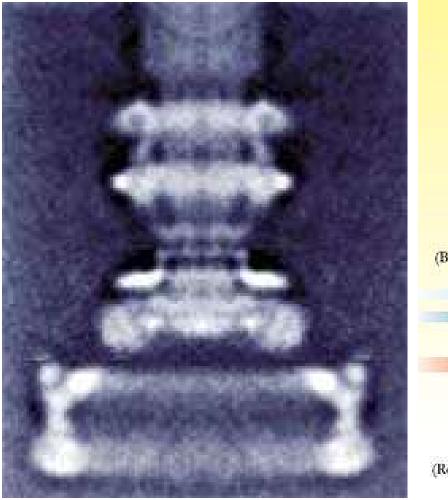
#### 2009 Edition

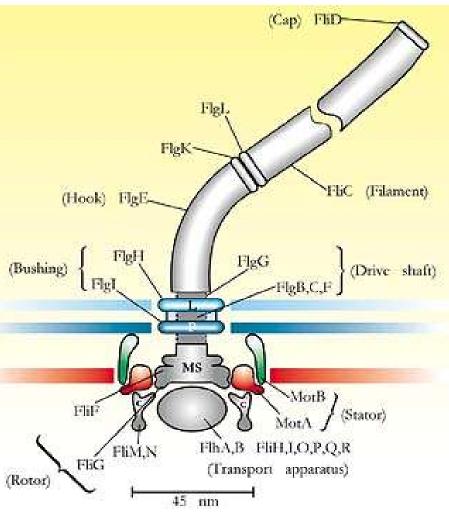
"The first three editions of the ERD Logic section have evaluated alternative logic technology entries in terms of their potential to displace scaled CMOS devices in high performance general purpose computing. The conclusion reached in those editions was that none of the alternative technologies surveyed had a high potential for displacing scaled CMOS devices on the ITRS roadmap scheduled for the 2020's."

Lots of hype in the press. Read ITRS for a more balanced evaluation.

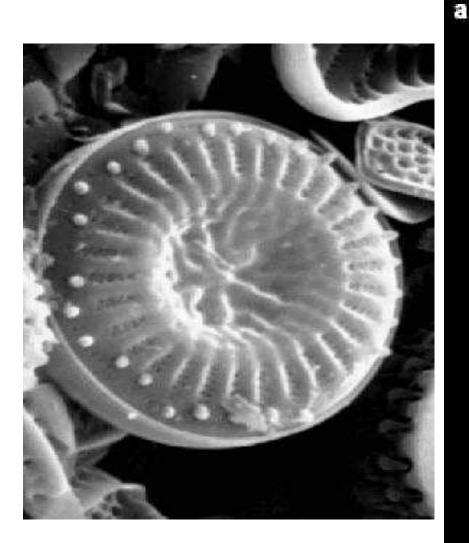
# Bottom-up technology d а ь DNA Origami ~ 100 nm (Images: Paul Rothemund) ođ 5)

## Bottom-up technology





Bacterial motor



Produced at room temperature from sunlight and seawater.

# New materials synthesis routes

V.C. Sundar, A.D. Yablon, J. L. Grazul, M. Ilan and J. Aizenberg, "Fibre-optical features of a glass sponge," Nature vol. 424 p. 899 (2003).



# Self-assembly of devices will be a key competence

- Self organization of structures from 100 microns to 0.1 nm
- Learn chemistry from biology
- Exploit biological infrastructure
  - Trees = self assembled solar cells, batteries
- Self assemble lithographically produced devices
  - lighting panels, solar cells